



P25117.A08

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Eiju KOMURO et al.

Group Art Unit : 1765

Appl. No. : 10/811,812

Examiner : M. DAHIMENE

Filed : March 30, 2004

Confirmation No. : 2851

For : METHOD OF MANUFACTURING A PIEZOELECTRIC THIN FILM
RESONATOR, MANUFACTURING APPARATUS FOR A
PIEZOELECTRIC THIN FILM RESONATOR, PIEZOELECTRIC
THIN FILM RESONATOR, AND ELECTRONIC COMPONENT

INTERVIEW SUMMARY

Commissioner for Patents
U.S. Patent and Trademark Office
Customer Service Window, Mail Stop Issue Fee
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Sir :

In accordance with the telephonic interview with the Examiner on March 15, 2007,
Applicants elected to cancel, without prejudice or disclaimer, non-elected claims 6-7 by
Examiner's Amendment.

Should the Examiner have any questions, the Examiner is invited to contact the
undersigned at the below-listed telephone number.

Respectfully Submitted,
Eiju KOMURO et al.

William Boshnick

William Boshnick
Reg. No. 44,550

May 30, 2007
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